

Notice of References Cited	Application/Control No. 10/552,970		Applicant(s)/Patent Under Reexamination CIRKEL ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0043291	11-2001	Kono et al.	349/12
*	B	US-2002/0190964	12-2002	Van Berkel, Cees	345/173
	C	US-			
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	F	US-			
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	I	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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